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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of : **Confirmation No. 1256**  
Yoshihiro GUNJI et al. : Docket No. 2001-1075A  
Serial No. 09/917,732 : Group Art Unit 1763  
Filed July 31, 2001 : Examiner Sylvia MacArthur

SUBSTRATE HOLDING APPARATUS AND  
SUBSTRATE POLISHING APPARATUS

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**AMENDMENT**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In response to the Office Action of December 22, 2003, the period for response to which having been extended by one month to April 22, 2004, kindly amend the above-referenced U.S. patent application as follows: